



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 28, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG761501781

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

10.17 X 7.13 X 4.23 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.90 CARAT

E

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

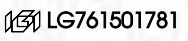
EXCELLENT

EXCELLENT

NONE

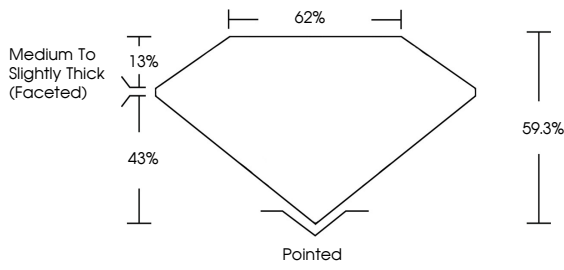
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

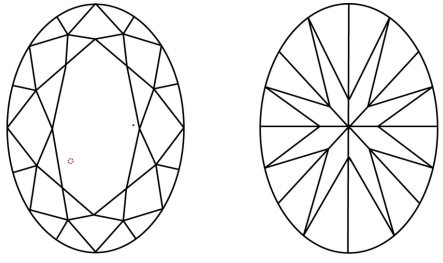


IGI LG761501781

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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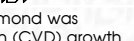
EXCELLENT

EXCELLENT

NONE

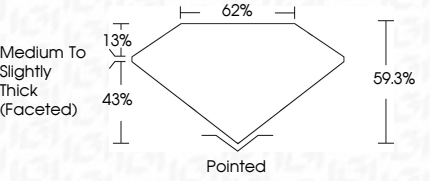
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IGI LG761501781

PROPORTIONS



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

IGI Logo

IGI



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December 28, 2025

IGI Report No LG761501781

OVAL BRILLIANT

10.17 X 7.13 X 4.23 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.90 CARAT

E

VVS 2

59.3%

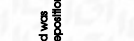
62%

Pointed

EXCELLENT

EXCELLENT

NONE



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